

WEST**Freeform Search****Database:** All Databases (USPT + EPAB + JPAB + DWPI + TDBD) 

@py<= 1998 and 134

Term:**Display**

20

Documents in Display Format:

TI

Generate: Hit List Hit Count Image**Search History**

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
ALL	@py<= 1998 and l34	335	<u>L36</u>
ALL	py<= 1998 and l34	358	<u>L35</u>
ALL	l7 same plasma	358	<u>L34</u>
ALL	increas\$ etch\$ rate same "he"	15	<u>L33</u>
ALL	l31 and l1	32	<u>L32</u>
ALL	mixture same l7	309	<u>L31</u>
ALL	@py<= 1998 and l29	124	<u>L30</u>
ALL	"He" same plasma same etch\$ rate	137	<u>L29</u>
ALL	etch\$ rate same helium volume	1	<u>L28</u>
ALL	l23 and l2	3	<u>L27</u>
ALL	l23 and l2	3	<u>L26</u>
ALL	l23 and l17	0	<u>L25</u>
ALL	l23 same l17	0	<u>L24</u>
ALL	l7 same Volume	93	<u>L23</u>
ALL	5443645[uref]	1	<u>L22</u>
ALL	l6 and (argon concentration)	0	<u>L21</u>
ALL	@py<= 1998 and l19	52	<u>L20</u>
ALL	l17 and l7	54	<u>L19</u>
ALL	l17 same l7	0	<u>L18</u>
ALL	etch\$ silicon oxide	1795	<u>L17</u>
ALL	l7 and l14	1	<u>L16</u>
ALL	l7 and l14	1	<u>L15</u>
ALL	216/68!.ccls.	69	<u>L14</u>
ALL	l12 and l7	2	<u>L13</u>
ALL	438/706!.ccls.	129	<u>L12</u>
ALL	l10 and l7	8	<u>L11</u>
ALL	252/79.1!.ccls.	683	<u>L10</u>
ALL	5645947[uref]	0	<u>L9</u>
ALL	l7 and l2	172	<u>L8</u>
ALL	"Ar" same "He" same "H.sub.2"	1190	<u>L7</u>
ALL	l5 and (etch\$ rate)	76	<u>L6</u>
ALL	l4 and (chamber)	210	<u>L5</u>
ALL	l2 and l3	252	<u>L4</u>
ALL	helium same argon same hydrogen	4911	<u>L3</u>
ALL	@py<= 1998 and L1	8425	<u>L2</u>
USPT	silicon oxide and (plasma or dry etch\$)	10454	<u>L1</u>